## Supporting Information

## In-situ Al<sub>2</sub>O<sub>3</sub> Incorporation Enhances the Efficiency of CuIn(S,Se)<sub>2</sub> Solar Cells Prepared from Molecular-Ink Solutions

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Figure S1. TG-DSC of ink made from CuCl-InCl<sub>3</sub>-thiourea dissolved in methanol.



**Figure S2.** Raman spectra measured on as-deposited (Al-CIS) and selenized (Al-CISSe) films. The Raman spectrum of the Al-CISSe is identical to that of standard CuInSe<sub>2</sub>, with a slight right-shift due to the presence of some sulfur in the film.<sup>1</sup>



Figure S3. Secondary electron images of (a) Al-CISSe and (b) CISSe films.



**Figure S4.** AES of oxygen region spectra taken from the bulk of (a) CISSe (72 spectra) and (b) Al-CISSe (83 spectra), excluding spectra from the interfaces (surface and Mo). (c) AES depth profiling of CISSe film.



**Figure S5.** (a) SEM-EDX mapping across the Al-CISSe film where  $AlO_x$  segregates were observed on the surface of the film and inside the bulk. Characteristic X-ray energies of Al and Se exhibit some overlap (Al-K $\alpha$ : 1.486 eV, Se-L $\alpha$ : 1.379 eV), as a result, their apparent distributions in the maps show some mirroring with each other, and AES was used to determine composition. (b) SEM-EDX mapping of the CISSe film. Note that the white agglomerates observed in both SEM images of Al-CISSe and CISSe films are byproducts of the focused ion beam (FIB) process used to prepare the samples.<sup>2</sup>



**Figure S6.** STEM high angle annular dark field (HAADF) image of Al-CISSe corresponding to the bright field image in Fig. 4a. Bright spots in Fig. 4a appear as dark in this image.



**Figure S7.** Diffuse reflectance spectrum of Al-CISSe and CISSe films and their Kubelka-Munk plots to estimate the optical band gaps.



**Figure S8.** SEM-EDX mapping of Al-CISSe device (SLG/Mo/Al-CISSe/CdS/ZnO/ITO). Note that X-ray energies of Al and Se (Al-K $\alpha$ : 1.486 eV, Se-L $\alpha$ : 1.379 eV), Cu and Zn (Cu-L $\alpha$ : 0.928 eV, Zn-L $\alpha$ : 1.012 eV) exhibit some overlap. The white agglomerates observed in the SEM image are byproducts of the FIB process, as observed also in Figure S5.

## References

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